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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Applicant : James A. Harrington, and Veena Gopal  
Serial No. : 10/764,101  
Filed : January 23, 2004  
For : A METHOD, AND ARTICLE OF THE  
METHOD, FOR FABRICATING A  
FLEXIBLE, HOLLOW WAVEGUIDE  
Examiner : Unknown  
Art Unit : 2874  
Confirmation No. : 7908  
Attorney Docket No. : 879.1.018

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: COMMISSIONER FOR PATENTS, ALEXANDRIA, VA 22313-1450	
ON	June 27, 2006
NAME	Kenneth Watov
SIGNATURE	<i>Kenneth Watov</i>

June 27, 2006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Transmitted herewith is an Information Disclosure Statement ("IDS") in the above-referenced Application, together with a Form-1449 listing all references cited and copy of each non-US Patent/Application reference.

No Office Action on the above-referenced Application has been received by Applicant, and therefore no fee for submitting this IDS is believed to be due. However, the Commissioner is hereby authorized to charge Deposit Account No. 23-0510 if any fee under 37 C.F.R. 1.17 is deemed necessary for the accompanying references to be considered by the Patent and Trademark Office.

All the references are in English and/or are cited in an accompanying English language version of the Search Report by another Patent Office, so that comment on the references by the Applicant is not required under 37 C.F.R. § 1.98(a).

Respectfully submitted,

A handwritten signature in black ink that reads "Kenneth Watov". The signature is fluid and cursive, with the first and last names being clearly legible.

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**Form PTO-1449**  
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SERIAL NO. 10/764,101

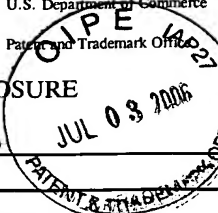
APPLICANT(S) James A. Harrington, and Veena Gopal

**INFORMATION DISCLOSURE**  
**CITATION**

(Use several sheets if necessary)

FILING DATE January 23, 2004

GROUP 2874


**U.S. PATENT DOCUMENTS**

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,815,627	9/29/1998	J. A. Harrington	385	125	
	5,567,471	10/22/1996	Harrington et al.	427	163.2	
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<b>Foreign Patent Documents</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

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Examiner

DATE CONSIDERED

\* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.